## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial No.: 09/891,611

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation No.: 8874

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND

METHOD OF MANUFACTURING DEVICES USING THE

**SYSTEM** 

Attorney Docket Number: 010817

Customer Number: 38834

## **AMENDMENT AFTER FINAL REJECTION**

Mail Stop AF Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: August 9, 2005

Sir:

This paper is filed in response to the Office Action dated April 12, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 19 of this paper.